



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: METALORGANIC CHEMICAL VAPOR DEPOSITION (MOCVD)
PROCESS AND APPARATUS TO PRODUCE MULTI-LAYER HIGH-
TEMPERATURE SUPERCONDUCTING (HTS) COATED TAPE

App. No.: 10/602,468 Filed: June 23, 2003

Examiner: Jennifer C. McNeil Group Art Unit: 1775

Customer No.: 34456 Confirmation No.: 2661

Atty. Dkt. No.: 1014-SP156-US

MS RCE
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN SUPPORT OF REQUEST FOR CONTINUED
EXAMINATION

Dear Sir:

In response to the Final Office Action mailed October 18, 2005, reconsideration and withdrawal of the rejections contained therein are respectfully requested for the following reasons.

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>4118100</u> .	
Elise K. Dougherty Typed or Printed Name	<u>E.K. Dougherty</u> Signature